

Applicant: YUICHI TAKEGAWA

Serial No.: TBA

Group Art Unit:

Filed: Herewith

Examiner:

Title: METHOD AND SYSTEM FOR DNA CHIP PRODUCTION

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.97 and 1.98**

Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure under 37 CFR \$1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached Form PTO-1449 and/or listed herein and which the Examiner may deem relevant to patentability of the claims of the above-identified application.

The relevance of these references to the subject matter of the present invention is given in the Background and Summary of the Invention in the specification of the present invention.

English abstracts of the Japanese Patent documents are submitted herewith.

In compliance with the concise explanation requirement under 37 CFR §1.98(a)(3) for foreign language documents, Applicant encloses herewith a copy of a corresponding foreign Search Report citing such documents, together with an English-language version (if not already included) of that portion of the Search Report indicating the degree of relevance found by the foreign office.

The submission of the listed documents is not intended as an admission that any such document constitutes prior art against the claims of the present application. Applicant does not waive any right to take any action that would be appropriate to antedate or otherwise remove any listed document as a competent reference against the claims of the present application.

Respectfully submitted,

November 30, 2001



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FORM PTO-1449	U.S. Department of Commerce Patent & Trademark Office	Attorney Docket No. 381NP/50668	Serial No. 09/980126
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant: Yuichi TAKEGEWA	
		Filing Date Herewith	Group

U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	TRANSLATION	
							Yes	No
	AK	2000-99577	12/2000	Japan			Abstract	
	AL	2000-57214	02/2000	Japan			Abstract	
	AM	2000-279169	10/2000	Japan			Abstract	
	AN	2000-295990	10/2000	Japan			Abstract	
	AO	2000-210082	08/2000	Japan			Abstract	
	AP	98/15908	04/1998	WO			Yes	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)									
	AQ	"Java, WebSphere" Nikkei Internet Technology,							
	AR	Copy of International Search Report							
	AS								

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication.	